

Docket: CU-3412

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE:

In re Application: Kiyoshi OOI et al.] GRP ART UNIT: 2811

Serial No: 10/692,836] Ex.: Nguyen, Cuong Guang

Filed: October 24, 2003]

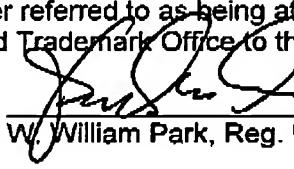
For: CAPACITOR AND MANUFACTURING METHOD THEREOF,
 SEMICONDUCTOR DEVICE AND SUBSTRATE FOR A SEMICONDUCTOR
 DEVICE

Certification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (703) 872-9306

Date of Fax Transmittal: September 14, 2004

I hereby certify that this paper (along with any paper referred to as being attached or enclosed)
 is being transmitted to the United States Patent and Trademark Office to the fax number and on
 the date indicated above.


 W. William Park, Reg. No. 55,523

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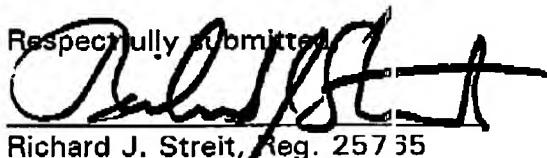
AUTHORIZATION TO ACT IN A REPRESENTATIVE CAPACITY

The practitioner W. William Park, Reg. No. 55,523 is authorized to conduct interviews and has the authority to bind the principal concerned. Furthermore, the practitioner is authorized to file correspondence in the above-identified application pursuant to 37 CFR 1.34, including to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

The practitioner named above does not have the authority to sign a request to change the correspondence address, a request for an express abandonment, a disclaimer, a power of attorney, or other document requiring the signature of the applicant, assignee of the entire interest or an attorney of record. If appropriate a separate Power of Attorney to the above named practitioner should be executed and filed in the United States Patent and Trademark Office.

Dated: September 14, 2004

Respectfully submitted,


 Richard J. Streit, Reg. 25735
 Ladas & Parry
 224 South Michigan Avenue
 Chicago, Illinois 60604
 (312) 427-1300